



OCT 17 2003

2823-
TJK/204

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Chang Gyu KIM et al.

Korean Application No. 2001-15415

Korean Filing Date: March 24, 2001

Serial No.: 10/001,314

Filed: November 14, 2001

) METHOD FOR FORMING ISOLATION
) LAYER OF SEMICONDUCTOR DEVICE

) Group Art Unit: 2823

) Examiner: N. Berezny

RECEIVED
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TECHNOLOGY CENTER 2800

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

Please find enclosed the following documents pertaining to the above-referenced application:

1. Response to Office Action (9 pages);
2. Petition for Extension of Time Under 37 C.F.R. 1.136(a) (in duplicate);
3. Check for \$110.00 (1 mo. extension fee);
4. Return Receipt Postcard

The Commissioner is hereby authorized to charge any necessary fees to Deposit Account 232126. In the event of non-payment or improper payment of a require fee, the Commissioner is hereby authorized to charge or credit Deposit Account No. 232126 as required to correct the error. A duplicate copy of this letter is enclosed for fee purposes.

Respectfully submitted

Date:

10/16/03

By:

Douglas S. Rupert
Attorney for Applicant
Reg. No. 44,434

Wildman, Harrold, Allen & Dixon LLP
225 W. Wacker Drive, Suite 3000
Chicago, Illinois 60606
Telephone: (312) 201-2000
Facsimile: (312) 201-2555

CERTIFICATE OF EXPRESS MAIL

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Date of Deposit: 10/16/03

I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. Christina A. Smala